www.olympus-ims.com/opto-digital/

- OLYMPUS CORPORATION is ISO14001 certified.
- OLYMPUS CORPORATION is FM553994/ISO9001 certified.

- This device is designed for use in industrial environments for the EMC performance (IEC61326-1 Class A device). Using it in a residential environment may affect other equipment in the environment.

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When You Need to See a New Dimension, Olympus Provides the Answer



DSX500, the opto-digital microscope is the new standard for industrial microscopes. Born of Olympus' leading-edge opto-digital technology, this scope offers operating simplicity and a level of reliability unheard of among so-called digital microscopes. Any operator, regardless of experience, can use Olympus DSX500 to get complete inspection and accurate analysis every time.

Superb Operating Simplicity

Absolute Performance Reliability

Opto-digital Microscope DSX500

DSX500 Offers a New World of Observation and Analysis

Various Observation Methods with Simple Operations. Quickly Achieve the Image Definition You Need for Observation

Can be used for any industrial microscopic observation method. Also, a new MIX observation method combines BF and DF. Where experts had to conduct observations before, now pressing a single button changes the image on screen, and you get the high-resolution images expected of high-end optical microscopes.



Bright-field observation. The most common method with optical microscopes.



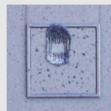
Dark-field observation. Illuminate from the side to Contrast observation. emphasize imperfections.



Differential Interference The method to use when Best method for identifying inspecting uneven surfaces. filter.



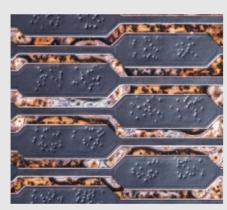
Polarized light observation. Used to inspect copper lines through a polarized



While observing samples with the bright-field measurement method, you can detect defects and imperfections without switching back and forth between bright-field and dark-field images.

Digital Clarity Exceeds the Naked Eye, with Superb High-definition Sample Surface Images

In addition to advanced optics, use of HDR (High Dynamic Range) clearly shows hard-to-see microscopic textures as well as samples prone to halation, which were difficult to see before.



Sample Surface Shown Clearly in 3D

Sample surface can be shown in 3D from any angle. Extended focal image maintains focus across the entire sample surface.



2D image with everything in focus 3D images at a touch

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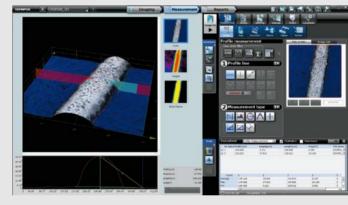
Panoramic Photos Include Areas beyond the Field of Vision

Panoramic photos let you easily take photos of areas beyond the field of vision, which are automatically synthesized into a screen image to show a very broad field in high definition. 2D, EFI, and 3D can all be synthesized.



Standard Features Enable a Huge Variety of Measurements, So All Your Measurement Objectives Are Met

All items for 2D and 3D industrial microscope measurements are standard features, so it is easy to quantify measurement results. In addition to the standard methods of surface measurement, profile measurement, uneven surface measurement, area and volume measurement, options include both caliper measurement and profile measurement.

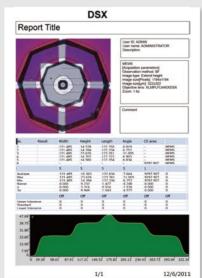


Quick Simple Measurement with a Report Function

One click sets the report function in motion to record and create a report of the images and results of measurements and observations. The system can be set to follow applications and greatly improve efficiency.



A click can generate a report



Report output



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Superb Operating Simplicity



Tutorial Mode

Eliminates the confusing aspects of operating a microscope. Just follow the suggestions the system gives for excellent output every time.

Advanced Mode

Makes jobs super easy for the experienced operator. Laid out for action. Powered controls make operation much speedier.



Operator Mode

This mode is customizable for speedy routine work. Most efficient when the same task is done repeatedly.



Three user-selectable modes — Choose your mode according to the measurement environment



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Operating Simplicity that Guides Operators to Optimum Output, Regardless of Their Experience

A new way to see. No peering through microscope eyepieces, because everything shows on the GUI screen. So you operate the scope with touch panel, mouse, or computer. What's more, virtually anybody can use this new operating system, whatever their experience. The screens guide the operator through the procedure, from inspection to measurement and analysis to final report. Short, simple steps. Quick results.

Three Modes to Set According to Operator Experience and Job Demands

Select Tutorial Mode or Advanced Mode to match the experience of the operator and the job at hand. And Advanced Mode can be customized to match operator experience or to do routine work. The operator's ID and password open the application, and it automatically sets the scope to the operator's preferred observation, analysis, or measurement settings along with the screen visual the operator normally uses.

New User Interface Changes Thinking about Microscope Operation

Where an operator had to make complicated adjustments before, with DSX500, it's simple. Once the sample is in place, everything is controlled by computer mouse, joystick, or touch screen – inspection position, focus, zoom, illumination, and choice of several inspection and operation methods. And you can easily find the inspection position you want, just by moving the image on the touch screen with your finger until it is in the right place. What's more, pinching—enlarging by spreading two fingers, reducing by bringing two fingers together—work on the DSX500 touch screen as well. All controls are direct and easily performed. Furthermore,auto-focus/auto-gain make sure illumination of and focus on the sample are correct.



GUI enables a direct, comfortable operation

Macro Map Always Shows Where You Are

Where conventional microscopes tend to lose focus in dark-field image, DSX500 stays in bright-field image mode even when changing observation methods. That means no confusion when increasing or reducing magnification. On the screen, a macro map shows the exact observing point. And the panoramic view function combines photos of several points into a single, larger image.



Optical Zoom Gives Close-up and Wide-angle as Needed

Change magnification as needed, even by slight degrees, with the view automatically in focus by AF function as the change is being made. A single lens gives you optics of 13x and digital zoom for a maximum of 30x. Plus, two lenses can be mounted at once for even greater magnification range. When inspecting a sample, you may want to switch lenses. When you do, DSX500 automatically adjusts lens and digital zoom to the exact same magnification level so you start anew at the very same place with the very same field of view. In addition, a specially designed long working distance lenses allow inspection and measurement of samples with uneven surfaces without worry of lens-sample contact.

Best image | Free | Fr

Best Image — Just choose the image you want from the previews on the screen



HDR — enables ultra high-definition inspection in dark-field and DIC images with one click



Operating Simplicity Lets Even the Inexperienced Observe Samples They Couldn't Before

The leading-edge digital technology of this microscope lets you see more than any other microscope can. Here-tofore, only experts with years of experience could adjust microscopes to achieve really good views of relevant samples. But DSX500 allows any operator to do that with a GUI screen. Now all it takes is a touch of the finger to follow a few easy steps to get exact output from inspection to diagnosis to pertinent reports.

Best Image Function Ensures Optimum Microscope Performance

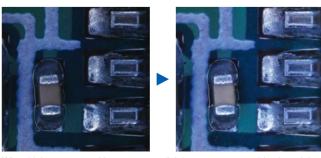
Now you can operate your microscope just by choosing, and leave the inspection method up to the microscope. That ensures the best possible image, whether looking for defects, uneven surfaces, or foreign objects. Anyone can operate the system, beginner or expert, and it can be customized for operator or operation. Put the inspection methods in memory, and whoever operates the scope will get the same results; no scattering.

HDR Gives Ultra High-Definition Visuals That Go Beyond the Human Eye

Dark-field risks blackout and bright-field risks halation, but the HDR (High Dynamic Range) function of DSX500 scopes synthesizes several images taken at different exposures to eliminate such problems. HDR promises high-fidelity images in which textures stand out and there is no halation, so defects that were undetectable now stand out.

WiDER Provides Easy Inspection of Samples with High Luminance Difference

If the shadowed areas black out, merely upping the illumination power is often not enough, because then halation occurs. Olympus intelligent image processing technology eliminates these problems with WiDER, a proprietary system ready to go at the click of a button. It takes care of the high contrast problems without reducing the frame rate. No blackouts. No halation.



When high contrast problems occur, a click lets you see everything in real time

Change Observation Methods with One Click – No Presetting Necessary

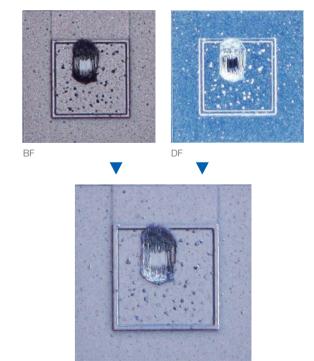
With virtually every industrial observation method at hand, it's easy to choose the proper one for the current task. Just choose the proper method with the click of a button. No complicated adjustments needed.



A click of a button gives you the image you want on screen

MIX Observation Method Easily Detects Defects and Imperfections

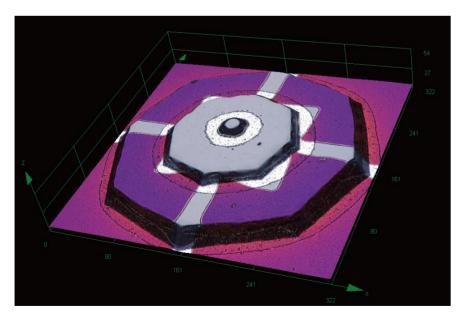
MIX combines bright-field (BF) measurement with dark-field (DF) LED illumination, something conventional microscopes cannot. With bright-field visibility and added dark-field detection capabilities, defects and imperfections can be detected while observing the sample.



MIX(BF+DF)



Panoramic photos — Use the mouse or your finger to select what you want in the view, and it's all linked together on screen



3D measurement — The click of a button turns the visual into 3D



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A Simple Operation Lets You See Now What You Couldn't See Before

The DSX500 requires no extensive knowledge or special techniques to show you exactly what you want to see. By calling on leading-edge electronic technology, you can now see what was unclear or impossible before. Of course, there are no difficult processes either. Just press the buttons on the menu to see what you want.

Panoramic Photos Include Areas beyond the Field of Vision

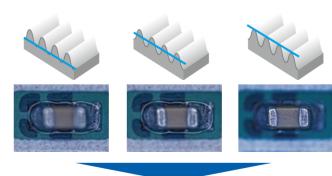
No such thing as "outside the field of vision." Just move the observation position on the screen, and the motorized stage will move the sample to that place. As the stage moves, the system automatically stitches images into a single large field of view, in real time. Where conventional microscopes reduce field area with increases in magnification, Panoramic View maintains the original field while giving close-up clarity – with 2D, expanded focus, or 3D, or any combination of one or all.

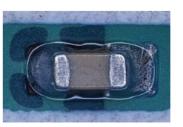
3D Photo Feature Shows the Sample as It Actually Is

Inspect or observe the sample as it is, because DSX500 can easily show it in three dimensions, and you can examine it from any angle.

EFI Capabilities Show Everything

Where conventional microscopes can focus only at one place, DSX500 Extend Focal Image (EFI) maintains focus across the entire target surface area. This makes uneven surfaces easy to inspect.





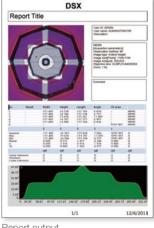
Even when using dark-field or DIC images, focus is automatically maintained across the field of view

The Report Function Gathers the Results Together Efficiently

With DSX500, you can do observation or measurement, and the operator's workflow includes preparation of relevant reports that can be output in rich text (rtf), or PDF formats.



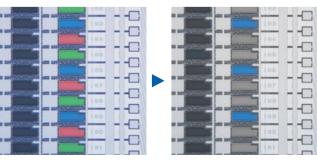
A click can generate a report



Report outpu

Color Enhancement Feature Shows Only What You Want to See

If you put what you need to see in color and leave the rest in monotone, it's much easier to find defects, if any exist. And you can photograph just that part, too, which makes reports even more effective.



Inspection is easier when you can highlight possible defects or contamination for inspection

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The optics technology and dedicated lenses — Complete with Olympus DNA



age 12

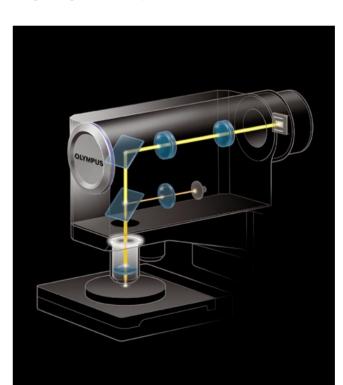
DNA from Olympus Gives DSX Microscopes the Ability to See What Digital Microscopes Cannot

Olympus guarantees the reliability of all DSX500 microscopes because they are born of Olympus optics and opto-digital technology. Halation is minimal and color reproduction is real.

And to make sure of that, Olympus uses the perfect combination of CCD chips and graphic boards. The sample is reproduced with such accuracy it's like a new dimension.

Ultra High-Quality Optics Let You See Into Another Dimension

Olympus DNA includes superior engineering and design capabilities as well as proven manufacturing quality. In the clear images produced by the DSX500 opto-digital microscope, you'll find neither flare nor distortion. That's something no digital microscope can claim.



The optics technology and dedicated lenses - complete with Olympus DNA

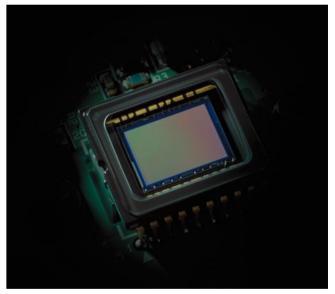
Dedicated DSX500 Field Lenses Make High-Grade Image Dissection a Simple Matter

These new lenses were especially designed and manufactured for DSX500 10x and 40x scopes. And they put high NA and long working distance together. Just zoom in electronically, and suddenly you've got extremely high resolution. On samples with very rough surfaces, high-resolution observation is simple and reliable. What's more, you can use UIS2 lenses, which provide high resolution and contrast.

18MP Images Reproduced in very High Resolution with High-Performance CCD*

As the engine that shows exactly what the high-quality optics reveal, exceptionally high-performance CCD reproduces the colors precisely. The image shift function ensures very high fidelity with fine detail processing of images, so the detail clarity extends from corner to corner.

*4800x3600 pixels, 3CCD mode conversion triples the pixel count



High-performance CCD

LED Illumination Gives Picture-Perfect Inspection with Much Less Energy

New LED illumination not only assures accurate observation, but also achieves both energy conservation and lower running costs. What's more, the light color temperature does not change with intensity. And the long working life of the elements means the scopes are virtually maintenance free.

Absolute Performance Reliability

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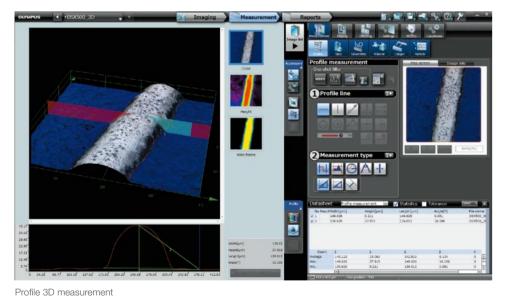


Caliner measurement



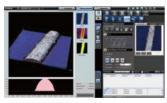
Particle analysis

Mechanized 2D measurement





BD Step measurement



3D Area and Volume measurement

2D and 3D measurements — enable measurement from every angle for various applications



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Precision Measurement with Absolute Reliability that Cannot Be Matched by Conventional Digital Microscopes

DSX500 scopes show Olympus' dedication to accurate measurement with its telecentric optics and frame design. The measurement capabilities are far and away more accurate than digital microscopes, with much greater reliability. The measurements are accurate and consistently repeatable, the test for reliable accuracy, always.

Accuracy and Repeatability Guaranteed

The DSX500 provides precise and repeatable measurements. Everything from an objective lens to the frame is manufactured in an Olympus factory under strict inspection criteria. The accuracy is guaranteed under the traceability system connecting to national standard.

*Calibration by Olympus or dealer specialists necessary



A traceability diagram from a DSX500 series opto-digital microscope

Auto-Calibration Eliminates Setup Scatter

Proper calibration is basic to precise measurement, and with Olympus DSX500, any operator can calibrate simply



and accurately. This eliminates scattering that naturally comes when different operators calibrate, and naturally increases reliability of readouts. In addition, the system's calibration report shows who did the calibration and when.

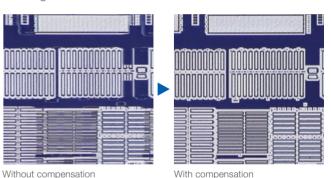
'A special calibration sample is necessary

Long List of Measurement Items Include Both 2D and 3D Choices

Any DSX500 microscope comes equipped for both 2D and 3D images. That means you can measure along the X,Y axis, or along X, Y, and Z axes. Observe, inspect, or measure from any angle. And the result of inspection can be reported by the same application.

Low Center of Gravity, Sturdy Frame, and Vibration Compensation Ensure a Steady Observation and Measurement Environment

The low center of gravity and sturdy frame of DSX500 scopes give sufficient stability for inspections at high magnification. Furthermore, vibration compensation absorbs any vibration that might affect inspection or measurement at high magnification and adjusts for any vibration-caused blur in 3D images.

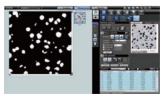


Telecentric Optics Ensure Precise Dimension

With telecentric optics, the size of the image does not alter with changes in focus position, unlike digital microscopes. What's more, trained staff check every scope upon delivery to ensure accuracy.

OLYMPUS Stream Can Analyze DSX500's Data

Metallographic evaluation, such as granularity analysis, is done with OLYMPUS Stream, an image-analysis program.



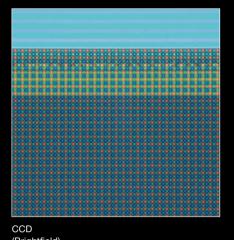


Particle analysis

Measurement

Cast-iron analysis

DSX500 Opto-digital Microscope Offers Operating Simplicity and Ultra High-resolution Visuals that Cannot Be Matched by Other Industrial Microscopes or Digital Microscope Systems

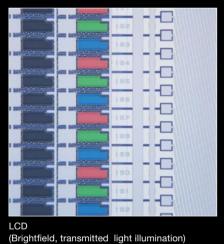






Particle on semiconductor wafer

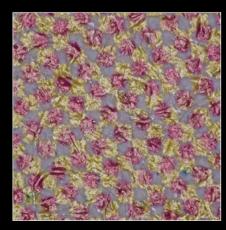
Particle on semiconductor wafer

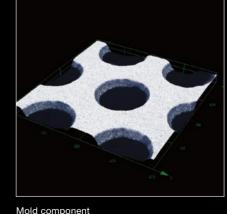


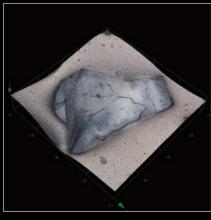




Coating surface (DIC+HDR)

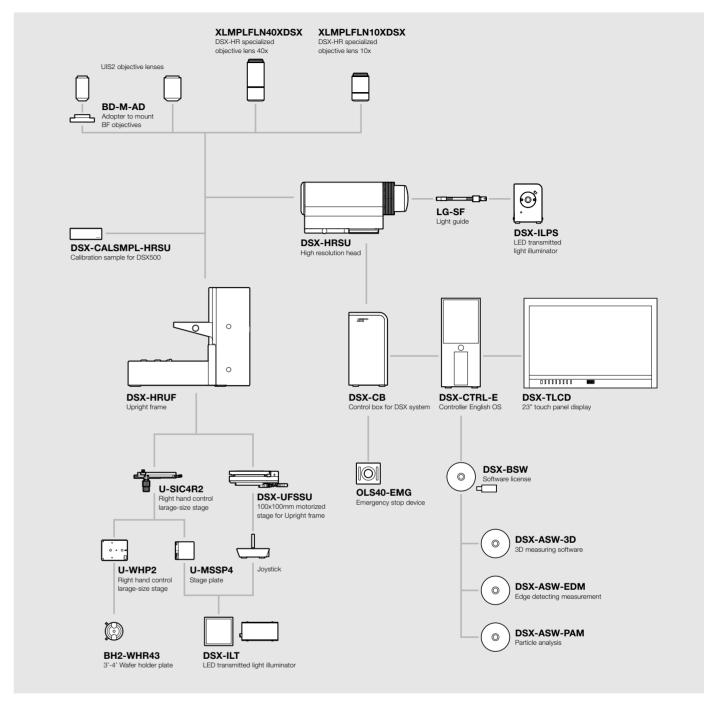






(Brightfield + HDR)

DSX500 System diagram







DSX500 Specifications

	Zoom ratio		13.5x optical zoom (0.26x-3.5x), 30x with digital zoom			
Main frame	Nosepiece(Manual)	No. of objective lens	Max 2 (restriction applies)			
		Mountable objective lens	DSX Dedicated objective lens	XLMPLFLN10X,XLMPLFLN40X		
			UIS2 objective lens	MPLFLN1.25X,MPLFLN2.5X,MPLFLN5XBDP,MPLFLN10XBDP, MPLFLN20XBDP,MPLFLN50XBDP,LMPLFLN10XBD,LMPLFLN20X, LMPLFLN50X,MPLAPON50X		
	Illumination	Embedded standard	Bright field: LED, Dark field: LED			
		Optional illumination	High intensity LED *1 / Transmitted LED			
	Camera	Image sensor	1/1.8 inch, 2.01 megapixels, Color CCD (Total pixels : 2.10 megapixels) Total pixels : 1688(H) x 1248(V) Available pixels : 1628(H) x 1236(V) Effective pixels : 1600(H) x 1200(V)			
		Cooling method	Peltier colling			
		Scan mode	Progressive scan			
		Frame rate	15fps / 27fps with banning mode			
		Image resolution	Normal : 1194×1194(1:1) / 1592×1194(4:3) Fine : 1194×1194(1:1) / 1592×1194(4:3) Super fine: 3594×3594(1:1) / 4792×3594(4:3)			
		Sensitivity	ISO100 / 200 / 400 / 800 / 1600 equivalent			
	Focusing part	Stroke	95 mm			
		Resolution	0.01 μm			
	Maximum specimen height	DSX	65 mm			
		UIS2	95 mm			
Motorized stage	DSX-UFSSU (Motorized)	Stroke	100 x 100 mm			
		Load capacity	3 kg			
	U-SIC4R (Manual)	Stroke	100 x 100 mm			
		Load capacity	1 kg			
LCD Monitor		Size	23" with Touch panel and Full HD color LCD monitor			
		Resolution	1920(H)x1080(V)			
Weight Approx. 38.6 kg (Main frame,			, Motorized stage, LCD Monitor, Control box, PC)			
Input rating		100-120V/220-240V, 185VA	A, 50/60Hz			
*1 Cannot be use	ed with the embedded standa	ard LED.				

^{*1} Cannot be used with the embedded standard LED.

DSX500 Series Objective Lens

Series	Model	Perforcal distance	N.A.	W.D. (mm)	Actual F.O.V. (µm) *3	Total Magnification *4
DOV dedicated distant	XLMPLFLN10XDSX *1	75	0.3	30.0	1,960-151	139x-1,803x
DSX dedicated objective lens	XLMPLFLN40XDSX *1	— 75 mm —	0.8	4.5	490-38	555x-7,211x
	MPLFLN1.25X *2		0.04	3.5	15,684-1,206	17x-225x
	MPLFLN2.5X *2	_	0.08	10.7	7,842-603	35x-451x
	MPLFLN5XBDP	_	0.15	12.0	3,921-302	69x-901x
	MPLFLN10XBDP		0.25	6.5	1,960-151	139x-1,803x
11100 - 121 - 121 - 121	MPLFLN20XBDP		0.4	3.0	980-75	277x-3,606x
UIS2 objective lens	MPLFLN50XBDP	— 45 mm —	0.75	1.0	392-30	693x-9,014x
	LMPLFLN10XBD		0.25	10.0	1,960-151	139x-1,803x
	LMPLFLN20XBD		0.4	12.0	980-75	277x-3,606x
	LMPLFLN50XBD	_	0.5	10.6	392-30	693x-9,014x
	MPLAPON50X *1		0.95	0.35	392-30	693x-9,014x

^{*1} DF and MIX are not available *2 Available for BF only *3 At aspect ratio 1:1 (with factory default value) *4 At aspect ratio 1:1

DSX Series





DSX500 Dimensions

